

SPECIFICATION

METHOD FOR PREPARING DDR TYPE ZEOLITE FILM, DDR TYPE
ZEOLITE FILM, AND COMPOSITE DDR TYPE ZEOLITE FILM,
5 AND METHOD FOR PREPARATION THEREOF

Technical Field

The present invention (a first aspect of the present invention) relates to a production method of a DDR type
10 zeolite membrane. More particularly, the present invention relates to a method for easily producing a DDR type zeolite membrane having an industrially acceptable thickness in a short period of time.

The present invention (a second aspect of the present
15 invention) relates to a DDR type zeolite membrane, a gas separation method, and a gas separation apparatus. More particularly, the present invention relates to a DDR type zeolite membrane that can separate one or more types of particular gas components from a mixed gas containing two
20 or more particular gas components.

The present invention (a third aspect of the present invention) relates to a DDR type zeolite membrane composite and a production method of the same. More particularly, the present invention relates to a DDR type zeolite membrane
25 composite that has high mechanical strength, can prevent occurrence of defects such as cracks due to thermal stress and so on, and can secure a sufficient flux, when a DDR type

zeolite membrane composite is used, for example, as a gas separation membrane, and a production method of the same.

Background Art

5 Zeolite is used as a catalyst, a catalyst carrier, an absorbent, or the like, and a zeolite laminated film formed on a porous substrate made of metal or ceramic is used for a gas separation membrane or a pervaporation membrane by making use of a molecular sieving effect of the zeolite. In
10 view of these circumstances, zeolite membranes using various porous substrates and production methods of the same have been proposed. Such a zeolite formed into a thin membrane is used as a molecular separation membrane of a gas separation membrane, a pervaporation membrane, or the like by its
15 molecular sieving effect.

 There are many types of zeolites such as LTA, MFI, MOR, AFI, FER, FAU, DDR depending on crystal structures. Among them, DDR (Deca-Dodecasil 3R) is a crystal mainly containing silica, and its pore is formed by a polyhedron with an oxygen
20 eight-membered ring, and a known diameter of the pore of the oxygen eight-membered ring is 4.4×3.6 angstroms (see W. M. Meier, D. H. Olson, Ch. Baerlocher, Atlas of zeolite structure types, Elsevier (1996)).

 A DDR type zeolite having such a structural feature is
25 a zeolite having a relatively smaller pore diameter, and can be applied to a molecular sieve membrane for separating a gas of low molecular weight such as carbon dioxide (CO_2),

methane (CH_4), ethane (C_2H_6) that are hard to separate by other zeolites such as MFI, MOR, AFI, FER, and FAU types.

There have been proposed only a few production methods for such DDR type zeolites. Some proposals have been made
5 on powder synthesis, but no proposals have been made on the synthesis of the membrane. As a related technique of the power synthesis that is one of the few proposals, for example, M. J. den Exter, J. C. Jansen, H. van Bekkum, Studies in Surface Science and Catalysis vol. 84, Ed. by J. Weitkamp
10 et. al., Elsevier (1994) 1159-1166 discloses a method for producing a DDR type zeolite powder by hydrothermal synthesis using tetramethoxysilane, 1-adamantanamine, ethylenediamine, or the like, as raw materials.

However, the method for producing a DDR type zeolite
15 powder requires hydrothermal synthesis using an autoclave at 160 °C for a long period of 25 days, and requires constant stirring of a raw material solution, thus is not a convenient method.

Further, this production method provides only a DDR type
20 zeolite powder with a crystal size of 5 to 25 μm , thus has a problem that it cannot produce a dense separation membrane having a sufficient thickness for a gas separation process in a petrochemical industry or the like.

The present invention (a first aspect of the present
25 invention) is made in view of the problems of the related art, and has an object to provide a method for easily producing a DDR type zeolite membrane having a thickness that is

acceptable in an industrial gas separation process or the like in a short period of time.

No conventional zeolite membrane has a pore diameter that can separate independently a molecule of a relatively
5 low molecular weight such as methane (CH_4), ethane (C_2H_6), propane (C_3H_8), carbon dioxide (CO_2), or the like contained in a natural gas.

Known as a refining method of a natural gas is a method using a separation membrane mainly containing an organic
10 substance that selectively passes carbon dioxide (CO_2) rather than methane (CH_4). However, an organic membrane has low mechanical strength and low heat resistance, is plasticized by carbon dioxide, and is deteriorated by liquid hydrocarbon. Thus, there is no membrane suitable for membrane separation
15 of a gas containing a molecule of a low molecular weight such as a natural gas.

The present invention (a second aspect of the present invention) is made in view of the above described problems, and has an object to provide a DDR type zeolite membrane having
20 high mechanical strength and high heat resistance, capable of causing hardly such problems as plasticization by carbon dioxide and deterioration by liquid hydrocarbon, and separating one or more types of particular gas components from a mixed gas containing two or more types of particular
25 gas components such as a natural gas; a gas separation method using a DDR type zeolite membrane; and a gas separation apparatus being comprised of a DDR type zeolite membrane.

Generally, a zeolite membrane formed into a thin membrane has low mechanical strength, and thus a zeolite membrane is formed on a porous substrate made of metal or ceramic to form a zeolite membrane composite to increase the mechanical strength. Besides the increase in the mechanical strength, such a zeolite membrane can form a thin zeolite membrane, and thus can increase a gas flux when the membrane is used as a gas separation membrane, compared to when used as a self-supported membrane of a zeolite alone.

10 For the zeolite membrane formed on the porous substrate, thermal expansion behaviors significantly differ between the porous substrate and the zeolite membrane, which may cause defects such as cracks in the zeolite membrane on the porous substrate when a structure-directing agent used in zeolite synthesis is removed by calcination.

Thus, Vroon et al. of University of Twente propose that the defects such as cracks can effectively prevented by making the thickness of zeolite membrane to be formed on an alumina substrate thinner (See Journal of Membrane Science 20 144 (1998) 65-76). However, the probability in the occurrence of defects such as cracks due to thermal stress can not be reduced sufficiently by simply making zeolite membrane thinner.

There are disclosed in JP-A-9-202615 a zeolite membrane 25 having a zeolite crystal in a porous substrate and a production method of the same. It describes that the occurrence of defects such as cracks due to thermal stress

in the thermal treatment process of the zeolite membrane and the like can be reduced by employing such a constitution that a porous substrate possesses zeolite crystal in the inside thereof.

5 However, there is a problem that the zeolite membranes disclosed in JP-A-9-202615 and the like can not be always applicable to all types of zeolites. For example, for an LTA type zeolite, defects such as cracks of a zeolite membrane formed on a porous substrate cannot be decreased. The above
10 described advantage varies, depending upon materials of the porous substrate, and for example, when alumina is used for a porous substrate, and an MFI type zeolite is used for a zeolite membrane, the defects such as cracks or the like occur with the use of the zeolite membrane only for several times.

15 Incidentally, in the case of zeolite membrane disclosed in JP-A-9-202615, a porous substrate of 0.5 mm or more thickness is used since an amount of raw material solution being present in the porous substrate is important. If a zeolite membrane composite thus configured is too thick when
20 used as a gas separation membrane, there is such a problem that pressure loss becomes large, thereby a sufficient gas flux can not be attained.

 The present invention (a third aspect of the present invention) is made in view of the above problems, and has
25 an object to provide a DDR type zeolite membrane composite that has high mechanical strength, can prevent occurrence of defects such as cracks due to thermal stress, and can secure

a sufficient flux, when a DDR type zeolite membrane composite is used as a gas separation membrane, and a production method of the same.

5 Disclosure of the Invention

According to the present invention (a first aspect of the present invention), there is provided a production method of a DDR type zeolite membrane, characterized in that a DDR type zeolite membrane is formed by carrying out hydrothermal
10 synthesis with using a raw material solution having a containing ratio of 1-adamantanamine to silica (1-adamantanamine/SiO₂) in a molar ratio of 0.03 to 0.4, a containing ratio of water to the silica (water/SiO₂) in a molar ratio of 20 to 500, and a containing ratio of
15 ethylenediamine to the 1-adamantanamine (ethylenediamine/1-adamantanamine) in a molar ratio of 5 to 32; and a DDR type zeolite powder to be a seed crystal, and forming a DDR type zeolite membrane therefrom.

In the present invention (the first aspect of the present
20 invention), it is preferable that a raw material solution has a containing ratio of 1-adamantanamine to silica (1-adamantanamine/SiO₂) of 0.05 to 0.25 in a molar ratio, a containing ratio of water to silica (water/SiO₂) of 28 to 220 in a molar ratio, and a containing ratio of ethylenediamine
25 to 1-adamantanamine (ethylenediamine/1-adamantanamine) of 8 to 24 in a molar ratio.

In the present invention (the first aspect of the present invention), it is preferable to prepare a raw material solution by dissolving 1-adamantanamine in ethylenediamine to prepare a 1-adamantanamine solution, and then mixing the
5 1-adamantanamine solution and said silica sol solution containing silica.

In the present invention (the first aspect of the present invention), it is preferable that hydrothermal synthesis is performed at 130°C to 200°C.

10 In the present invention (the first aspect of the present invention), it is preferable that a DDR type zeolite powder is dispersed in a raw material solution, and a DDR type zeolite membrane is formed on a porous substrate.

15 In the present invention (the first aspect of the present invention), it is preferable that a DDR type zeolite powder is deposited on a porous substrate, and a raw material solution is brought into contact with the porous substrate to form a DDR type zeolite membrane on the porous substrate.

20 In the present invention (the first aspect of the present invention), it is preferable that a DDR type zeolite membrane formed on the porous substrate has a thickness of 0.1 to 50 μm , and the porous substrate is in the form of a plate, a cylinder, a honeycomb, or a monolith being formed from a plurality of cylindrical tubes integrated.

25 As described above, according to the production method of a DDR type zeolite membrane of the present invention (the first aspect of the present invention), a DDR type zeolite

membrane having a thickness of being preferably employable in an industrial gas separation process may be easily produced in a short period of time since it is hydrothermally synthesized by using a raw material solution containing raw materials such as 1-adamantanamine as a structure-directing agent in a predetermined composition ratio, and a DDR type zeolite powder to be a seed crystal. A DDR type zeolite membrane obtained by the production method according to the present invention (the first aspect of the present invention) may be suitably usable as a separation membrane to be used for separating various substances or a membrane reactor, for example, in combination with a catalyst or the like, in a petrochemical industry.

According to the present invention (a second aspect of the present invention), there is provided a DDR type zeolite membrane, characterized in that it is formed as a membrane on a substrate and its main component is silica, and that its single gas permeances at room temperature and 100°C are different among at least two types of gases selected from a group consisting of gases capable of forming a mixed gas at room temperature and 100°C. There is provided a DDR type zeolite membrane, characterized in that its single gas permeances at room temperature and 100°C as to at least two types of gases selected from a group consisting of carbon dioxide (CO₂), hydrogen (H₂), oxygen (O₂), nitrogen (N₂), methane (CH₄), normal butane (n-C₄H₁₀), isobutane (i-C₄H₁₀), sulfur hexafluoride (SF₆), ethane (C₂H₆), ethylene (C₂H₄),

propane (C_3H_8), propylene (C_3H_6), carbon monoxide (CO), and nitrogen monoxide (NO) are different among said at least two gases, respectively.

In the present invention (the second aspect of the present invention), it is preferable that a gas permeance of carbon dioxide (CO_2) at room temperature is 1.0×10^{-9} ($mol \cdot m^{-2} \cdot s^{-1} \cdot Pa^{-1}$) or more.

In the present invention (the second aspect of the present invention), it is preferable that a gas permeance of carbon dioxide (CO_2) at $100^\circ C$ is 5.0×10^{-10} ($mol \cdot m^{-2} \cdot s^{-1} \cdot Pa^{-1}$) or more.

In the present invention (the second aspect of the present invention), it is preferable that each separation factor of CO_2/CH_4 in a mixed gas containing carbon dioxide (CO_2) and methane (CH_4) in an equimolar amount (a value of respective ratios of gas fluxes of CO_2 at room temperature and $100^\circ C$ to gas fluxes of CH_4 at room temperature and $100^\circ C$ when the mixed gas permeates the DDR type zeolite membrane) is 2 or more at room temperature and $100^\circ C$, respectively.

In the present invention (the second aspect of the present invention), it is preferable that each value of a ratio of a single gas permeance of carbon dioxide (CO_2) at room temperature and $100^\circ C$ to a single gas permeance of any one of hydrogen (H_2), oxygen (O_2), nitrogen (N_2), methane (CH_4), normal butane ($n-C_4H_{10}$), isobutane ($i-C_4H_{10}$), and sulfur hexafluoride (SF_6) at room temperature and $100^\circ C$ is 2 or more, respectively.

In the present invention (the second aspect of the present invention), it is preferable that each value of a ratio of a single gas permeance of hydrogen (H_2) at room temperature and $100^\circ C$ to a single gas permeance of any one of oxygen (O_2), nitrogen (N_2), methane (CH_4), normal butane ($n-C_4H_{10}$), isobutane ($i-C_4H_{10}$), and sulfur hexafluoride (SF_6) at room temperature and $100^\circ C$ is 2 or more, respectively.

In the present invention (the second aspect of the present invention), it is preferable that each value of a ratio of a single gas permeance of oxygen (O_2) at room temperature and $100^\circ C$ to a single gas permeance of any one of nitrogen (N_2), methane (CH_4), normal butane ($n-C_4H_{10}$), isobutane ($i-C_4H_{10}$), and sulfur hexafluoride (SF_6) at room temperature and $100^\circ C$ is 1.1 or more, respectively.

In the present invention (the second aspect of the present invention), it is preferable that each value of a ratio of a single gas permeance of nitrogen (N_2) at room temperature and $100^\circ C$ to a single gas permeance of any one of methane (CH_4), normal butane ($n-C_4H_{10}$), isobutane ($i-C_4H_{10}$), and sulfur hexafluoride (SF_6) at room temperature and $100^\circ C$ is 2 or more, respectively.

In the present invention (the second aspect of the present invention), it is preferable that each value of a ratio of a single gas permeance of methane (CH_4) at room temperature and $100^\circ C$ to a single gas permeance of any one of normal butane ($n-C_4H_{10}$), isobutane ($i-C_4H_{10}$), and sulfur

hexafluoride (SF_6) at room temperature and 100°C is 2 or more, respectively.

In the present invention (the second aspect of the present invention), it is preferable that each value of a
5 ratio of a single gas permeance of normal butane ($\text{n-C}_4\text{H}_{10}$) at room temperature and 100°C to a single gas permeance of isobutane ($\text{i-C}_4\text{H}_{10}$) or sulfur hexafluoride (SF_6) at room temperature and 100°C is 1.1 or more, respectively.

In the present invention (the second aspect of the
10 present invention), it is preferable that each value of a ratio of a single gas permeance of isobutane ($\text{i-C}_4\text{H}_{10}$) at room temperature and 100°C to a single gas permeance of sulfur hexafluoride (SF_6) at room temperature and 100°C is 1.1 or more, respectively.

15 In the present invention (the second aspect of the present invention), it is preferable that a separation factor each of H_2/CH_4 in a mixed gas containing hydrogen (H_2) and methane (CH_4) in an equimolar amount at room temperature and 100°C (each value of a ratio of a gas flux of H_2 at room
20 temperature and 100°C to a gas flux of CH_4 at room temperature and 100°C when the mixed gas permeates a DDR type zeolite membrane) is 2 or more, respectively.

In the present invention (the second aspect of the present invention), it is preferable that a separation factor
25 each of $\text{C}_2\text{H}_4/\text{C}_2\text{H}_6$ in a mixed gas containing ethylene (C_2H_4) and ethane (C_2H_6) in an equimolar amount at room temperature and 100°C is 1.5 or more.

In the present invention (the second aspect of the present invention), it is preferable that a separation factor each of O_2/N_2 in the air at room temperature and $100^\circ C$ is 1.5 or more.

5 In the present invention (the second aspect of the present invention), there is provided a gas separation method for separating at least one type of gas component from a mixed gas containing at least two types of gas components selected from a group consisting of carbon dioxide (CO_2), hydrogen (H_2),
10 oxygen (O_2), nitrogen (N_2), water (H_2O), methane (CH_4), normal butane ($n-C_4H_{10}$), isobutane ($i-C_4H_{10}$), sulfur hexafluoride (SF_6), ethane (C_2H_6), ethylene (C_2H_4), propane (C_3H_8), propylene (C_3H_6), carbon monoxide (CO), and nitrogen monoxide (NO), using the above described DDR type zeolite membrane.

15 In the present invention (the second aspect of the present invention), it is preferable that carbon dioxide (CO_2) is selectively separated from a mixed gas containing carbon dioxide and methane (CH_4).

In the present invention (the second aspect of the present invention), there is provided a gas separation
20 apparatus being comprised of the above described DDR type zeolite membrane in order to separate at least one type of gas component from a mixed gas containing at least two types of gas components selected from a group consisting of carbon
25 dioxide (CO_2), hydrogen (H_2), oxygen (O_2), nitrogen (N_2), water (H_2O), methane (CH_4), normal butane ($n-C_4H_{10}$), isobutane ($i-C_4H_{10}$), sulfur hexafluoride (SF_6), ethane (C_2H_6), ethylene

(C_2H_4), propane (C_3H_8), propylene (C_3H_6), carbon monoxide (CO), and nitrogen monoxide (NO).

In the case of the present invention (the second aspect of the present invention), a gas separation apparatus being
5 comprised of the above described DDR type zeolite membrane capable of selectively separating carbon dioxide (CO_2) from a mixed gas containing carbon dioxide and methane (CH_4) is preferable.

As described above, a DDR type zeolite membrane of the
10 present invention (the second aspect of the present invention) may separate at least one type of particular gas components from a mixed gas containing at least two types of particular gas components such as a natural gas since its respective single gas permeances of at least two kinds of
15 gases selected from the group consisting of a plurality of the particular gases are different each other. Since it is formed on the substrate, it has a high mechanical strength. And, since it is a DDR type zeolite membrane (an inorganic substance), it shows a high heat resistance, and can prevent
20 plasticization caused by carbon dioxide, and deterioration by liquid hydrocarbon.

According to the gas separation method of the present invention (the second aspect of the present invention), since the gas separation is carried out by using a DDR type zeolite
25 membrane of the present invention (the second aspect of the present invention), at least one type of particular gas components can be separated from at least two types of gases

selected from the group consisting of a plurality of particular gases. Especially, carbon dioxide (CO_2) may be selectively separated from the mixed gas containing carbon dioxide and methane (CH_4). According to the gas separation apparatus of the present invention (the second aspect of the present invention), since it is comprised of a DDR type zeolite membrane of the present invention (the second aspect of the present invention) and a gas is separated by means of this membrane, at least one type of particular gas components can be separated from at least two types of gases selected from the group consisting of a plurality of particular gases.

According to the present invention (a third aspect of the present invention), there is provided a DDR type zeolite membrane composite, characterized in that there is provided with a porous substrate, and a DDR type zeolite layer deposited within pores of the porous substrate and having a thickness 5 to 50 times of a mean pore diameter of the porous substrate; said DDR type zeolite layer composed of a DDR type zeolite having been disposed within pores of at least one surface of the porous substrate.

In a DDR type zeolite membrane composite according to the present invention (the third aspect of the present invention), it is preferable that the a DDR type zeolite membrane composite further comprises a DDR type zeolite layer deposited outside of the substrate, which is made of a DDR type zeolite and has a thickness of 30 μm or less, on a surface

of the porous substrate on which the DDR type zeolite layer deposited within pores of substrate is disposed.

In a DDR type zeolite membrane composite according to the present invention (the third aspect of the present invention), it is preferable that the mean pore diameter of the porous substrate is 0.05 to 10 μm .

According to the present invention (the third aspect of the present invention), there is provided a production method of a DDR type zeolite membrane composite, characterized by forming a raw material solution having a mixing ratio of 1-adamantanamine to silica (1-adamantanamine (mol)/silica (mol)) of 0.03 to 0.4, and a mixing ratio of water to silica (water (mol)/silica (mol)) of 20 to 500, and immersing a porous substrate in thus obtained raw material solution for hydrothermal synthesis, thereby forming a DDR type zeolite layer deposited within pores of substrate having a thickness 5 to 50 times of a mean pore diameter of the porous substrate, and being composed of a DDR type zeolite, which is disposed within pores of at least one surface of the porous substrate.

In the production method of a DDR type zeolite membrane composite according to the present invention (the third aspect of the present invention), it is preferable that a DDR type zeolite layer deposited outside of the substrate, which is made of a DDR type zeolite and has a thickness of 30 μm or less, is formed on a surface of the porous substrate

on which the DDR type zeolite layer deposited within pores of substrate is disposed.

In the production method of a DDR type zeolite membrane composite according to the present invention (the third
5 aspect of the present invention), it is preferable to use a porous substrate has a mean pore diameter of 0.05 to 10 μm as said porous substrate.

In the production method of a DDR type zeolite membrane composite according to the present invention (the third
10 aspect of the present invention), it is preferable to perform the hydrothermal synthesis at 130°C to 200°C in order to obtain said DDR type zeolite membrane composite.

In the production method of a DDR type zeolite membrane composite according to the present invention (the third
15 aspect of the present invention), one may use, as said raw material solution, the one containing further a DDR type zeolite powder to be a seed crystal, or one may immerse a resultant prepared by depositing a DDR type zeolite powder to be a seed crystal on the surface of said porous substrate
20 in said raw material solution.

According to the present invention (the third aspect of the present invention), there is provided a DDR type zeolite membrane composite not only having high mechanical strength, but also being capable of securing a sufficient
25 flux when used, for example, as a gas separation membrane. The production method of a DDR type zeolite membrane composite according to the present invention (the third

aspect of the present invention) allows a DDR type zeolite membrane composite to be easily produced at low cost.

Brief Description of the Drawings

5 Figure 1 shows an electron microphotograph of a cross section of a DDR type zeolite membrane produced in Example 13 of the present invention (a first aspect of the present invention).

10 Figure 2 shows an electron microphotograph of a surface of a DDR type zeolite membrane produced in Example 13 of the present invention (the first aspect of the present invention).

15 Figure 3 schematically illustrates a configuration of a gas permeation test apparatus to be used in gas permeation tests (1) and (2) in the present invention (the first aspect of the present invention).

 Figure 4 shows a bar graph of permeances of permeation gases in the gas permeation test (1) in the present invention (the first aspect of the present invention).

20 Figure 5 shows a bar graph of permeances of permeation gases in a mixed gas permeation test in the present invention (the first aspect of the present invention).

 Figure 6 shows a cross sectional view of an embodiment of a gas separation apparatus according to the present invention (a second aspect of the present invention).

25 Figure 7 schematically illustrates a configuration of a gas permeation test apparatus to be used in a gas permeation

test in the present invention (the second aspect of the present invention).

Figure 8 shows a schematic cross sectional view of a DDR type zeolite membrane composite according to an embodiment of the present invention (a third aspect of the present invention).

Figure 9 shows an electron microphotograph of a cross section of a DDR type zeolite membrane composite produced in Example 38 of the present invention (the third aspect of the present invention).

Figure 10 shows an electron microphotograph of a surface of a DDR type zeolite membrane composite produced in Example 38 of the present invention (the third aspect of the present invention).

Figure 11 schematically illustrates a configuration of a gas permeation test apparatus to be used in a gas permeation test in the present invention (the third aspect of the present invention).

Figure 12 shows thermal expansion behaviors of a DDR type zeolite and alumina in the present invention (the third aspect of the present invention).

Best Mode for Carrying out the Invention

Now, embodiments of the present invention will be described. The present invention is not limited to the embodiments described below, and it is to be understood that appropriate modifications or improvements in design may be

made based on ordinary knowledge of those skilled in the art without departing from the scope of the present invention.

The present invention (a first aspect of the present invention) is a production method of a DDR type zeolite membrane, and it provides a production method of a DDR type zeolite membrane, characterized in that a raw material solution having a containing ratio of 1-adamantanamine to silica (1-adamantanamine/SiO₂) in a molar ratio of 0.03 to 0.4, a containing ratio of water to silica (water/SiO₂) in a molar ratio of 20 to 500, and a containing ratio of ethylenediamine to 1-adamantanamine (ethylenediamine/1-adamantanamine) in a molar ratio of 5 to 32, and a DDR type zeolite powder to be a seed crystal are used for hydrothermal synthesis to form a DDR type zeolite membrane. Details thereof will be now described. Hereinafter, a containing ratio (a molar ratio) of 1-adamantanamine to silica is referred to as a "1-adamantanamine/SiO₂ ratio", a containing ratio (a molar ratio) of water to silica is referred to as a "water/SiO₂ ratio", and a containing ratio (a molar ratio) of ethylenediamine to 1-adamantanamine is referred to as an "ethylenediamine/1-adamantanamine ratio".

In the present invention (the first aspect of the present invention), 1-adamantanamine is used as a structure-directing agent for forming a DDR type zeolite membrane. First, 1-adamantanamine and silica sol, water, ethylenediamine, and other additives, if required, are used to prepare a raw material solution. Using, for example, a

trace amount of sodium aluminate as an additive allows Al to replace part of Si that constitutes a DDR type zeolite membrane. Such replacement can add catalysis or the like to a DDR type zeolite membrane to be formed, besides a separation
5 function. In preparation of a raw material solution, a 1-adamantanamine/SiO₂ ratio, a water/SiO₂ ratio, and an ethylenediamine/1-adamantanamine ratio are precisely adjusted in the present invention.

When the 1-adamantanamine/SiO₂ ratio is below 0.03,
10 1-adamantanamine as the structure-directing agent is insufficient to form a DDR type zeolite membrane, which is not preferable. When the 1-adamantanamine/SiO₂ ratio exceeds 0.4, a DDR type zeolite membrane can be formed, but 1-adamantanamine is too much to act as the structure-
15 directing agent, and the addition of expensive 1-adamantanamine in such a larger amount is not preferable in view of production costs.

In terms of forming a DDR type zeolite membrane considering the production costs, the 1-adamantanamine/SiO₂
20 ratio is preferably 0.05 to 0.25, and more preferably 0.05 to 0.12.

When the water/SiO₂ ratio is below 20, an SiO₂ concentration of a raw material solution is too high to form a dense DDR type zeolite membrane, which is not preferable,
25 and when the water/SiO₂ ratio exceeds 500, the SiO₂ concentration of a raw material solution is too low to form a DDR type zeolite membrane, which is not preferable. In

terms of forming the dense DDR type zeolite membrane, the water/SiO₂ ratio is preferably 28 to 220, and more preferably 28 to 120.

1-Adamantanamine is a solid compound at normal
5 temperature, and it is sometimes hard to dissolve completely to be a uniform solution in preparation of a raw material solution. When a raw material solution with 1-
10 adamantanamine remaining as powder is used, a DDR type zeolite membrane having a uniform crystal size and thickness is sometimes hard to produce. Thus, if one prepares a raw material solution by adding ethylenediamine thereto, one may dissolve 1-adamantanamine easily thereinto, thereby one may produce a dense DDR type zeolite membrane having a uniform crystal size and thickness.

15 The ethylenediamine/1-adamantanamine ratio below 5 is insufficient to easily dissolve 1-adamantanamine, and the ethylenediamine/1-adamantanamine ratio exceeding 32 is not preferable because ethylenediamine that does not contribute to reaction becomes excessive to increase production costs.
20 In terms of easily dissolving 1-adamantanamine, and producing a DDR type zeolite membrane having a uniform crystal size and thickness, the ethylenediamine/1-adamantanamine ratio is preferably 8 to 24, and more preferably 10 to 16.

25 In the present invention (the first aspect of the present invention), 1-adamantanamine is previously dissolved in ethylenediamine to prepare a 1-adamantanamine solution. It

is preferable to use a raw material solution prepared by mixing 1-adamantanamine solution thus prepared with a silica sol solution containing silica; this is because 1-adamantanamine can be more easily and completely dissolved, and a dense DDR type zeolite membrane having a uniform crystal size and thickness can be produced. The silica sol solution can be prepared by dissolving fine powdery silica in water or hydrolyzing an alkoxide, but a commercially available silica sol may be used by adjusting a silica concentration thereof.

In the present invention (the first aspect of the present invention), a DDR type zeolite powder is used in producing a DDR type zeolite membrane, and it is preferable to disperse a DDR type zeolite powder in a prepared raw material solution. A DDR type zeolite powder may become a seed crystal, and is effective to facilitate crystal growth. This accelerates the formation of a DDR type zeolite membrane, and easily provides a dense membrane thereof. A general stirring method may be used as a method for dispersing a DDR type zeolite powder in a raw material solution, but other methods such as ultrasonic treatment may be used, and uniform dispersion allows a denser DDR type zeolite membrane with a uniform thickness to be formed.

A raw material solution in which a DDR type zeolite powder to be the seed crystal is dispersed is placed in a vessel, for example, a pressure-resistant vessel, together with a support material for forming a membrane thereon, and

subjected to hydrothermal synthesis, thus allowing a DDR type zeolite membrane to be produced.

In the present invention (the first aspect of the present invention), a temperature in the hydrothermal synthesis is preferably 130°C to 200°C, more preferably 140°C to 180°C, and most preferably 150°C to 160°C. The hydrothermal synthesis performed at a temperature below 130°C is not preferable because a DDR type zeolite membrane is hard to form, and the hydrothermal synthesis performed at a temperature beyond 200°C is not preferable because a DOH phase that is a different phase is formed.

A treatment period for the hydrothermal synthesis may be 1 to 10 days. Thus, according to the present invention (the first aspect of the present invention), a DDR type zeolite membrane having a sufficient thickness (40 to 125 μm) as a self-supported membrane can be produced in an extremely short period of time, compared to a conventional production method of a DDR type zeolite.

In the present invention (the first aspect of the present invention), a porous substrate is used as a support material on which a DDR type zeolite membrane is formed in the hydrothermal synthesis, thus a DDR type zeolite membrane can be formed on the porous substrate. The porous substrate has three-dimensionally communicated many pores, and possesses gas permeance. A pore diameter of the porous substrate on a forming side of a DDR type zeolite membrane is preferably 0.003 to 10 μm . This is because a pore diameter of equal to

or less than $0.003\text{ }\mu\text{m}$ causes too high resistance when a gas permeates, and a pore diameter of more than $10\text{ }\mu\text{m}$ tends to cause defects in a DDR type zeolite membrane. In the present invention (the first aspect of the present invention), a
5 porous substrate made of ceramic such as alumina, zirconia, or mullite, or glass, zeolite, clay, metal, carbon, or the like as a raw material can be satisfactorily used. A porous substrate of alumina is preferable in view of a pore diameter and strength. The porous substrate is preferably in the form
10 of a plate, a cylinder, a honeycomb, or a monolith having a plurality of cylindrical tubes integrated. The "monolith" in the present invention (the first aspect of the present invention) refers to a plurality of cylindrical tubes integrated and having a plurality of axial communication
15 holes.

If a DDR type zeolite membrane is formed on the porous substrate, its mechanical strength is increased; thus formed membrane may have a smaller thickness than the self-supported membrane does. At this time, a DDR type zeolite membrane may
20 be 0.1 to $50\text{ }\mu\text{m}$ in the thickness, and is preferably 1 to $25\text{ }\mu\text{m}$ in the thickness.

In the present invention (the first aspect of the present invention), it is also preferable, in order to form a dense DDR type zeolite membrane having a uniform thickness, that
25 a DDR type zeolite powder is previously deposited on a porous substrate, instead of dispersing a DDR type zeolite powder to be a seed crystal in a raw material solution, and a porous

substrate on which a DDR type zeolite powder is deposited is brought into contact with a raw material solution to form a DDR type zeolite membrane on the porous substrate.

"Depositing a DDR type zeolite powder on the porous substrate" refers to a state where a DDR type zeolite powder to be a seed crystal is placed on a surface of the porous substrate on which a DDR type zeolite membrane is to be formed, but a firm adhesion is not necessarily required. "Bringing a porous substrate into contact with a raw material solution" refers to bringing a surface of the porous substrate on which a DDR type zeolite powder to be a seed crystal is placed into contact with the raw material solution. Thus, a DDR type zeolite powder is substantially brought into contact with the raw material solution. In order to deposit a DDR type zeolite powder on a porous substrate, for example, a DDR type zeolite powder may be dispersed in water to prepare a dispersion solution with an appropriate concentration, and an appropriate amount of dispersion solution may be applied to the surface of the porous substrate on which a DDR type zeolite membrane is to be formed. As an application method, dropping, dipping, spin coating, printing, or the like can be selected, depending on purposes.

Now, embodiments of the present invention (a second aspect of the present invention) will be described in detail with reference to the drawings.

A DDR type zeolite membrane according to the embodiment is obtained by forming a DDR type (Deca-Dodecasil 3R) zeolite

on a substrate in the form of a membrane (membrane forming).
A DDR type zeolite is a crystal mainly containing silica,
and its many pores are formed by a polyhedron with an
eight-membered ring of an oxygen atom, and a pore diameter
5 of a part formed by the eight-membered ring of the oxygen
atom is 4.4×3.6 angstroms (see W. M. Meier, D. H. Olson,
Ch. Baerlocher, Atlas of zeolite structure types, Elsevier
(1996)).

The method for forming a DDR type zeolite on the
10 substrate in the form of the membrane is not limited, but
the method described below is preferable.

1-adamantanamine, silica, and water are mixed in a
predetermined mixing ratio to prepare a raw material solution.
Then, a solution in which a DDR type zeolite powder is
15 dispersed is coated to a substrate. Hydrothermal synthesis
is performed with immersing the substrate on which a DDR type
zeolite powder has been deposited in a raw material solution
to obtain a DDR type zeolite membrane. Ethylenediamine may
be mixed into a raw material solution. When a DDR type
20 zeolite membrane is formed on the substrate as described
above, a membrane formed on the substrate has high mechanical
strength, allowing use under high pressure.

A material of a substrate used in the embodiment is not
limited, but a ceramic porous substrate such as an alumina
25 porous substrate is preferable. The porous substrate
facilitates gas permeation to increase gas treatment
efficiency. Further, the ceramic porous substrate

increases mechanical strength of a DDR type zeolite membrane formed on the substrate. Using a substrate having a property of passing a particular gas such as a palladium metal substrate that passes hydrogen, or a perovskite type ceramic substrate that passes oxygen is also preferable in separating the particular gas.

"Porous" means, for example, having three-dimensionally communicated many micropores, and a pore diameter is preferably 0.003 to 10 μm , and more preferably 0.005 to 5 μm . A diameter below 0.003 μm causes high resistance when a gas permeates, and a diameter exceeding 10 μm tends to cause a pin-hole in a DDR type zeolite membrane, which are not preferable.

A DDR type zeolite membrane has different single gas permeances at room temperature and 100°C respectively as to at least two types of gases selected from a group consisting of gases capable of forming a mixed gas at room temperature and 100°C. Furthermore, each single gas permeance at room temperature and 100°C as to at least two types of gases selected from a group consisting of carbon dioxide (CO_2), hydrogen (H_2), oxygen (O_2), nitrogen (N_2), water (H_2O), methane (CH_4), normal butane ($n\text{-C}_4\text{H}_{10}$), isobutane ($i\text{-C}_4\text{H}_{10}$), sulfur hexafluoride (SF_6), ethane (C_2H_6), ethylene (C_2H_4), propane (C_3H_8), propylene (C_3H_6), carbon monoxide (CO), and nitrogen monoxide (NO) are different, respectively among said at least two types of gases.

The gas permeance refers to the amount of moles (mol) of a gas that permeates the membrane per unit area (m^2), unit pressure (Pa), and unit time (s) at a predetermined temperature. Especially, a gas permeance obtained by a gas permeation test using one component of gas as a test gas is referred to as a single gas permeance.

Since it has the different gas permeances as to the above-mentioned particular gases (carbon dioxide, hydrogen, oxygen, nitrogen, water vapor, methane, normal butane, isobutane, sulfur hexafluoride, ethane, ethylene, propane, propylene, carbon monoxide, and nitrogen monoxide), as is discussed above, one or more types of particular gas components may be separated from a mixed gas containing two or more particular gas components such as a natural gas. This DDR type zeolite membrane has high heat resistance, and the plasticization caused by carbon dioxide and the deterioration by liquid hydrocarbon hardly occur, not likely the membrane composed of an organic substance.

A DDR type zeolite membrane according to this embodiment has especially high gas permeance of carbon dioxide among the particular gases. It is preferable that the gas permeance at room temperature is 1.0×10^{-9} ($\text{mol} \cdot \text{m}^{-2} \cdot \text{s}^{-1} \cdot \text{Pa}^{-1}$) or more, and the gas permeance at 100°C is 5.0×10^{-10} ($\text{mol} \cdot \text{m}^{-2} \cdot \text{s}^{-1} \cdot \text{Pa}^{-1}$) or more. The separation of carbon dioxide from hydrogen, oxygen, nitrogen, methane, normal butane, isobutane, sulfur hexafluoride, ethane, ethylene, propane,

propylene, carbon monoxide, and nitrogen monoxide may be done easily therefrom.

In a DDR type zeolite membrane according to the embodiment, it is preferable that each separation factor of CO_2/CH_4 in a mixed gas containing carbon dioxide (CO_2) and methane (CH_4) in an equimolar amount is 2 or more at room temperature and 100°C , respectively. More practically, the separation factor of CO_2/CH_4 is preferably 10 or more, and more preferably 20 or more. This allows a mixed gas of carbon dioxide and methane to be easily separated into each gas.

The separation factor of CO_2/CH_4 in a mixed gas of CO_2 and CH_4 refers to a value of a ratio of a gas flux of CO_2 to a gas flux of CH_4 when the mixed gas permeates a DDR type zeolite membrane at a predetermined temperature divided by a value of a ratio of a partial pressure of CO_2 to a partial pressure of CH_4 in the mixed gas. This is expressed by the following equation (1), and a value of the equation (1) is herein calculated at room temperature and 100°C .

(Separation factor of CO_2/CH_4) = $(Q_A/Q_B)/(P_A/P_B)$... (1)

wherein Q_A denotes a gas flux ($\text{mol}\cdot\text{m}^{-2}\cdot\text{s}^{-1}$) of CO_2 when the mixed gas permeates the membrane at a predetermined temperature, Q_B denotes a gas flux ($\text{mol}\cdot\text{m}^{-2}\cdot\text{s}^{-1}$) of CH_4 when the mixed gas permeates the membrane at a predetermined temperature, P_A denotes a partial pressure (Pa) of CO_2 in the mixed gas before permeating the membrane at a predetermined temperature, and

P_B denotes a partial pressure (Pa) of CH_4 in the mixed gas before permeating the membrane at a predetermined temperature.

In a DDR type zeolite membrane according to the embodiment, it is preferable that each separation factor of H_2/CH_4 in a mixed gas containing hydrogen (H_2) and methane (CH_4) in an equimolar amount at room temperature and $100^\circ C$ is 2 or more, respectively. This allows the mixed gas of H_2 and CH_4 to be easily separated into each gas. The separation factor of H_2/CH_4 refers to a value of a ratio of a gas flux of H_2 to a gas flux of CH_4 when a mixed gas containing H_2 and CH_4 in an equimolar amount permeates a DDR type zeolite membrane at a predetermined temperature.

It is preferable that each separation factor of C_2H_4/C_2H_6 in a mixed gas containing ethylene (C_2H_4) and ethane (C_2H_6) in an equimolar amount at room temperature and $100^\circ C$ is 1.5 or more, respectively. This allows the mixed gas of C_2H_4 and C_2H_6 to be easily separated into each gas. The separation factor of C_2H_4/C_2H_6 refers to a value of a ratio of a gas flux of C_2H_4 to a gas flux of C_2H_6 when the mixed gas containing C_2H_4 and C_2H_6 in an equimolar amount permeates a DDR type zeolite membrane at a predetermined temperature.

It is preferable that each separation factor of O_2/N_2 in the air at room temperature and $100^\circ C$ is 1.5 or more, respectively. This allows N_2 and O_2 to be easily separated from the air. The separation factor of O_2/N_2 refers to a value of a ratio of a gas flux of O_2 to a gas flux of N_2 when the

air permeates a DDR type zeolite membrane at a predetermined temperature divided by a value (1/4) of a ratio of a partial pressure of O_2 to a partial pressure of N_2 in the air.

In a DDR type zeolite membrane according to the
5 embodiment, a value of a ratio of a single gas permeance of carbon dioxide (CO_2) at room temperature and $100^\circ C$ to a single gas permeance of any one of hydrogen (H_2), oxygen (O_2), nitrogen (N_2), methane (CH_4), normal butane ($n-C_4H_{10}$), isobutane ($i-C_4H_{10}$), and sulfur hexafluoride (SF_6) at room
10 temperature and $100^\circ C$ is preferably 2 or more, and more preferably 10 or more, respectively. If the value of the ratio is below 2, separation efficiency of CO_2 is significantly reduced, which is impractical.

The value of the ratio of the gas permeance refers to
15 a value of a ratio of a single gas permeance of a gas A (referred to as R_A) to a single gas permeance of a gas B (referred to as R_B), that is, a calculated value of R_A/R_B .

In a DDR type zeolite membrane according to the
embodiment, a value of a ratio of a single gas permeance of
20 hydrogen (H_2) at room temperature and $100^\circ C$ to a single gas permeance of any one of oxygen (O_2), nitrogen (N_2), methane (CH_4), normal butane ($n-C_4H_{10}$), isobutane ($i-C_4H_{10}$), and sulfur hexafluoride (SF_6) at room temperature and $100^\circ C$ is preferably 2 or more, respectively. If the value of the ratio is below
25 2, separation of H_2 may sometimes become difficult.

In a DDR type zeolite membrane according to the
embodiment, each value of a ratio of a single gas permeance

of oxygen (O_2) at room temperature and $100^\circ C$ to a single gas permeance of any one of nitrogen (N_2), methane (CH_4), normal butane ($n-C_4H_{10}$), isobutane ($i-C_4H_{10}$), and sulfur hexafluoride (SF_6) at room temperature and $100^\circ C$ is preferably 1.1 or more, respectively. Each value of a ratio of a single gas permeance of nitrogen at room temperature and $100^\circ C$ to a single gas permeance of any one of methane, normal butane, isobutane, and sulfur hexafluoride at room temperature and $100^\circ C$ is preferably 2 or more, respectively. Each value of a ratio of a single gas permeance of methane at room temperature and $100^\circ C$ to a single gas permeance of any one of normal butane, isobutane, and sulfur hexafluoride at room temperature and $100^\circ C$ is preferably 2 or more, respectively. Each value of a ratio of a single gas permeance of normal butane at room temperature and $100^\circ C$ to a single gas permeance of isobutane or sulfur hexafluoride at room temperature and $100^\circ C$ is preferably 1.1 or more, respectively. Each value of a ratio of a single gas permeance of isobutane at room temperature and $100^\circ C$ to a single gas permeance of sulfur hexafluoride at room temperature and $100^\circ C$ is preferably 1.1 or more, respectively.

The single gas permeances of carbon dioxide (CO_2), hydrogen (H_2), oxygen (O_2), nitrogen (N_2), methane (CH_4), normal butane ($n-C_4H_{10}$), isobutane ($i-C_4H_{10}$), and sulfur hexafluoride (SF_6) at room temperature and $100^\circ C$ have the above described relationship, thus the eight types of gases

can be efficiently separated using a DDR type zeolite membrane according to the embodiment.

This embodiment of the present invention (a second aspect of the present invention) is directed to a gas separation method for separating at least one type of gas component from a mixed gas containing at least two types of gases selected from a group consisting of gases capable of forming a mixed gas at room temperature and 100°C. Furthermore, it is directed to a gas separation method for separating at least one type of gas component from a mixed gas, wherein the mixed gas contains at least two types of gas components selected from a group consisting of carbon dioxide (CO₂), hydrogen (H₂), oxygen (O₂), nitrogen (N₂), water (H₂O), methane (CH₄), normal butane (n-C₄H₁₀), isobutane (i-C₄H₁₀), sulfur hexafluoride (SF₆), ethane (C₂H₆), ethylene (C₂H₄), propane (C₃H₈), propylene (C₃H₆), carbon monoxide (CO), and nitrogen monoxide (NO).

One may separate effectively said at least one type of gas by using this DDR type zeolite membrane according to the embodiment, since it has different single gas permeances, respectively at room temperature and 100°C among least two types of gases selected from selected from a group consisting of carbon dioxide (CO₂), hydrogen (H₂), oxygen (O₂), nitrogen (N₂), water (H₂O), methane (CH₄), normal butane (n-C₄H₁₀), isobutane (i-C₄H₁₀), sulfur hexafluoride (SF₆), ethane (C₂H₆), ethylene (C₂H₄), propane (C₃H₈), and propylene (C₃H₆).

Specifically, one may use satisfactorily this gas separation method according to the embodiment for the selective separation of carbon dioxide (CO_2) from a mixed gas containing carbon dioxide and methane (CH_4).

5 Figure 6 shows a cross sectional view of an embodiment of a gas separation apparatus according to the present invention (the second aspect of the present invention). In the gas separation apparatus 240 in Figure 6, a cap-like metal member 201 includes an annular gland 202 and a lower cap-like
10 stopper 203, and an annular metal member 204 includes an annular gland 205 and an upper annular stopper 206. The annular metal member 204 (the upper annular stopper) is joined to a flange 208 having a through hole 207 by welding or the like. A cap 245 is secured to a pressure vessel 244
15 by a securing member 246 via a flange 208.

A gas separation body 210 having a DDR type zeolite membrane 230 formed on a cylindrical porous substrate 231 is fitted between the cap-like metal member 201 and the annular metal member 204. Gland packings 211, 212 are placed
20 as seal members in contact with an outer surface of the gas separation body 210 in the cap-like metal member 201 and the annular metal member 204. A stuffing box 213 that can house at least one gland packing 211 and one gland packing 212 may be provided, and the gland packings 211, 212 may be housed
25 therein. However, the gland packings 211, 212 have to be in immediate contact with the outer surface of the gas separation body 210.

The annular packing glands 202, 205 can apply a fastening pressure to the gland packings 211, 212 axially of the cylindrical porous substrate 231, and the lower cap-like stopper 203 and the upper annular stopper 206 restrain axial movement of the gland packings 211, 212 caused by the application of the fastening force to the gland packings 211, 212. The gland packings 211, 212 with their movement restrained closely fit inward radially of the gas separation body 210, that is, in a direction perpendicular to a surface of the DDR type zeolite membrane 230, at an appropriate pressure with some actual deformation, to secure gas-tightness between the gas separation body 210, the cap-like metal member 201 and the annular metal member 204. The stuffing box 213 can effectively transmit the fastening pressure applied to the gland packings 211, 212 housed therein to the gas separation body 210.

A contact portion between the annular packing gland 202 and the lower cap-like stopper 203, and a contact portion between the annular gland 205 and the upper annular stopper 206 may be formed with a thread groove 220 in order to apply and hold the tightening pressure to the gland packings 211, 212. Peripheries of the annular packing glands 202, 205, the lower cap-like stopper 203, and the upper annular stopper 206 may be formed with chamfered portions 221 in order to facilitate screwing with a wrench.

The porous substrate 231 used in the gas separation apparatus according to the embodiment supports a DDR type

zeolite membrane to increase mechanical strength. "Porous" herein means, for example, having three-dimensionally communicated many micropores, and a pore diameter is preferably 0.003 to 10 μm , and more preferably 0.005 to 5 μm . If a diameter is below 0.003 μm , the resistance becomes high when a gas permeates, and if a diameter exceeds 10 μm , a pin-hole tends to be formed in a DDR type zeolite membrane, which are not preferable. A porous substrate of ceramic is preferable, and a porous substrate of alumina is more preferable.

A mechanism for sealing between the cap-like metal member 201 or the annular metal member 204, and the outer surface of the gas separation body 210 does not have to be a gland packing, but seal may be made by a rubber O-ring, glass joining, brazing, an organic adhesive, or the like.

When the gas separation apparatus according to the embodiment is used to separate a mixed gas, the mixed gas is first introduced from an inlet 242 formed in a pressure vessel 244. The introduced mixed gas permeates the DDR type zeolite membrane of the gas separation body 210, and enters the gas separation body 210. The gas having permeated the DDR type zeolite membrane from the gas separation body 210 becomes a gas with a particular component concentrated (separated), and is discharged from an outlet 241 formed in a cap 245 through the through hole 207 formed in the flange 208. A gas discharged from an outflow port 243 formed in the pressure vessel 244 without permeating the DDR type zeolite

membrane loses the component concentrated (separated) in the gas having permeated the DDR type zeolite membrane, and becomes a gas with other components relatively concentrated (separated).

5 The gas separation apparatus according to the embodiment can separate at least one type of gas component from a mixed gas containing at least two types of gas components selected from a group consisting of carbon dioxide (CO_2), hydrogen (H_2), oxygen (O_2), nitrogen (N_2), water (H_2O),
 10 methane (CH_4), normal butane ($n\text{-C}_4\text{H}_{10}$), isobutane ($i\text{-C}_4\text{H}_{10}$), sulfur hexafluoride (SF_6), ethane (C_2H_6), ethylene (C_2H_4), propane (C_3H_8), propylene (C_3H_6), carbon monoxide (CO), and nitrogen monoxide (NO).

 The gases can be efficiently separated because the gas
 15 separation apparatus according to this embodiment is a gas separation apparatus being comprised of a DDR type zeolite membrane according to the above-mentioned embodiment, which has different single gas permeances respectively at room temperature and 100°C among at least two types of gases
 20 selected from the group consisting of carbon dioxide (CO_2), hydrogen (H_2), oxygen (O_2), nitrogen (N_2), water (H_2O), methane (CH_4), normal butane ($n\text{-C}_4\text{H}_{10}$), isobutane ($i\text{-C}_4\text{H}_{10}$), sulfur hexafluoride (SF_6), ethane (C_2H_6), ethylene (C_2H_4), propane (C_3H_8), propylene (C_3H_6), carbon monoxide (CO), and nitrogen
 25 monoxide (NO).

 The gas separation apparatus according to this embodiment is suitable for selectively separating carbon

dioxide (CO_2) from a mixed gas containing carbon dioxide and methane (CH_4).

Now, embodiments of the present invention (a third aspect of the present invention) will be described in detail with reference to the drawings.

An embodiment of a DDR type zeolite membrane composite according to the present invention (the third aspect of the present invention) will be described. As shown in Figure 8, the DDR type zeolite membrane composite 301 according to the embodiment includes a porous substrate 302, and a DDR type zeolite membrane 306 made of a DDR type zeolite. The DDR type zeolite membrane 306 includes a DDR type zeolite layer deposited within pores of substrate 305 and a DDR type zeolite layer deposited outside of the substrate 304. The DDR type zeolite layer deposited within pores of substrate 305 is disposed within pores 303 of one surface of the porous substrate 302, and has a thickness 5 to 50 times of a mean pore diameter of the porous substrate. On the other hand, the DDR type zeolite layer deposited outside of the substrate 304 is disposed on a surface of the porous substrate 302 on which the DDR type zeolite layer deposited within pores of substrate 305 is disposed, and has a thickness of 30 μm or less.

In this embodiment, for example, the mean pore diameter of the porous substrate 302 is 0.6 μm , the thickness of the DDR type zeolite layer deposited within pores of substrate 305 is 10 times of the mean pore diameter of the porous

substrate 302, namely, 6 μm . The thickness of the DDR type zeolite layer deposited outside of the substrate 304 is 7 μm .

Such a configuration provides high mechanical strength,
5 can prevent occurrence of defects such as cracks due to thermal stress, and can secure a sufficient flux, for example, when the DDR type zeolite membrane composite 301 according to the embodiment is used as a gas separation membrane.

As the porous substrate 302 used in the embodiment, a
10 porous substrate made of ceramic such as alumina, zirconia, and mullite, or glass, zeolite, clay, metal, carbon, or the like can be satisfactorily used. The mean pore diameter of the porous substrate 302 is not limited, but a porous substrate with a mean pore diameter of 0.05 to 10 μm may be
15 satisfactorily used. For the porous substrate 302, a porous substrate 302a in an area with the DDR type zeolite layer deposited within pores of substrate 305 and a porous substrate 302b in other areas may be the same or different. In the porous substrate, the mean pore diameter on a side
20 with a DDR type zeolite layer is preferably 0.05 to 10 μm , and the mean pore diameter on a part without a DDR type zeolite layer may be larger than the values.

A DDR type zeolite used in the embodiment is a crystal mainly containing silica, and its pore is formed by a
25 polyhedron with an eight-membered ring of oxygen.

A forming method of a DDR type zeolite layer deposited outside of the substrate 304 according to the embodiment is

not limited, for example, a DDR type zeolite layer deposited outside of the substrate 304 can be formed by immersing the porous substrate 302 in a raw material solution used for forming a DDR type zeolite to perform hydrothermal synthesis.

5 When the porous substrate 302 is immersed in the raw material solution, the pores 303 of the porous substrate 302 is impregnated with the raw material solution to form the DDR type zeolite layer deposited within pores of substrate 305. At this time, using a raw material solution having a
10 relatively high concentration within a range of a raw material solution used in forming a DDR type zeolite can facilitate forming the DDR type zeolite layer deposited within pores of substrate 305 within the pores 303 of the porous substrate 302.

15 In this embodiment, the thickness of a DDR type zeolite layer deposited within pores of substrate 305 is 5 to 50 times of the mean pore diameter of the porous substrate 302, but is more preferably 5 to 10 times thereof. If the thickness is below 5 times of the mean pore diameter, occurrence of
20 defects such as cracks due to thermal stress cannot be restrained in a heat treatment process or the like of the DDR type zeolite membrane 306. If the thickness of the DDR type zeolite layer deposited within pores of substrate 305 exceeds 50 times of the mean pore diameter, pressure loss
25 becomes excessive, and thus when the DDR type zeolite membrane composite 301 is used as a gas separation membrane, a sufficient flux cannot be secured. Further, depositing the

DDR type zeolite within the pores 303 of the porous substrate 302 takes too much time.

In this embodiment, the thickness of the DDR type zeolite layer deposited outside of the substrate 304 disposed on the surface of the porous substrate 302 is 30 μm or less, but is more preferably 10 μm or less. When the DDR type zeolite membrane composite 301 includes the DDR type zeolite layer deposited within pores of substrate 305 with a sufficient thickness, the DDR type zeolite layer deposited outside of the substrate 304 is not always required. If the thickness of the DDR type zeolite layer deposited outside of the substrate 304 exceeds 30 μm , defects such as cracks due to thermal stress may increase in a heat treatment processing or the like of the DDR type zeolite membrane 306.

The thickness of the porous substrate 302 is not limited.

The thickness of a DDR type zeolite layer deposited outside of the substrate 304, and the thickness of the DDR type zeolite layer deposited within pores of substrate 305 may be set as desired by controlling composition of a raw material solution, synthesizing temperature, and synthesizing time.

A DDR type zeolite membrane composite 301 configured as described above can be effectively used as a gas separation membrane, and has a high separation property of carbon dioxide (CO_2) from methane (CH_4).

Next, an embodiment of a production method of a DDR type zeolite membrane composite according to the present

invention (the third aspect of the present invention) will be described. The production method of a DDR type zeolite membrane composite according to the embodiment is characterized by forming a raw material solution having a mixing ratio of 1-adamantanamine to silica (1-adamantanamine (mol)/silica (mol)) of 0.03 to 0.4, and a mixing ratio of water to silica (water (mol)/SiO₂ (mol)) of 20 to 500, immersing a porous substrate in thus formed raw material solution for hydrothermal synthesis, and forming a DDR type zeolite layer comprising a DDR type zeolite that are deposited within pores of the substrate on least one surface thereof and having a thickness 5 to 50 times of a mean pore diameter of the porous substrate.

In this embodiment, it is preferable to form a DDR type zeolite layer deposited outside of the substrate on a surface of the porous substrate, on which the DDR type zeolite layer deposited within pores of substrate is formed; said layer being made of a DDR type zeolite and having a thickness of 30 μ m or less.

One may form easily at a low cost a DDR type zeolite membrane composite capable of providing high mechanical strength, preventing occurrence of defects such as cracks due to thermal stress, and securing a sufficient flux, when, for example, the DDR type zeolite membrane is used as a gas separation membrane, with the employment of such a configuration.

The 1-adamantanamine functions as a structure-directing agent for forming a DDR type zeolite membrane constituted by a DDR type zeolite layer deposited within pores of substrate and a DDR type zeolite layer deposited
5 outside of the substrate. Other additives may be added to a raw material solution used in the embodiment.

As the porous substrate used in the embodiment, a porous substrate made of ceramic such as alumina, zirconia, and mullite, or glass, zeolite, clay, metal, carbon, or the like
10 can be satisfactorily used.

In this embodiment, the mixing ratio of 1-adamantanamine to silica (1-adamantanamine (mol)/SiO₂ (mol)) is 0.03 to 0.4, and the mixing ratio of water to silica (water (mol)/SiO₂ (mol)) is 20 to 500. When the mixing ratio of
15 1-adamantanamine to silica is below 0.03, 1-adamantanamine as the structure-directing agent is insufficient to form a DDR type zeolite membrane, which is not preferable. When the mixing ratio of 1-adamantanamine to silica exceeds 0.4, a DDR type zeolite membrane can be formed, but 1-adamantanamine
20 is too sufficient to act as the structure-directing agent, and the addition of expensive 1-adamantanamine in a larger amount is not preferable in view of production costs.

The mixing ratio of 1-adamantanamine to silica is preferably 0.03 to 0.25, and more preferably 0.05 to 0.125,
25 from the viewpoint of forming a DDR type zeolite membrane considering the production costs.

It is not preferable to form a dense DDR type zeolite membrane if the mixing ratio of water to SiO_2 is below 20 since a silica concentration of a raw material solution is too high, and it is not preferable to form a DDR type zeolite membrane if the mixing ratio of water to silica exceeds 500 since the silica concentration of a raw material solution is too low. The mixing ratio of water to silica is preferably 20 to 224, and more preferably 28 to 112 from the viewpoint of forming the dense DDR type zeolite membrane.

10 A raw material solution is generally mixed to have a high concentration within a range of a raw material solution being usable for forming a DDR type zeolite. The formation of a DDR type zeolite layer deposited within pores of substrate within the pores of a porous substrate may be accelerated by using a raw material solution having such a high concentration.

A raw material solution constituted as described above with ethylenediamine added to have a mixing ratio of ethylenediamine to 1-adamantanamine (ethylenediamine (mol)/1-adamantanamine (mol)) of 8 to 32 to be prepared is preferably used as a raw material solution of the embodiment. One may dissolve easily 1-adamantanamine by preparing a raw material solution with addition of ethylenediamine, and one may form a DDR type zeolite membrane having a uniform crystal size and thickness.

In this embodiment, the thickness of a DDR type zeolite layer deposited within pores of substrate is 5 to 50 times

of the mean pore diameter of the porous substrate, but is more preferably 5 to 10 times thereof. If the thickness of a DDR type zeolite layer deposited within pores of substrate is below 5 times of the mean pore diameter, the occurrence
5 of defects such as cracks due to thermal stress cannot be restrained in a heat treatment process or the like of a DDR type zeolite membrane. If the thickness of a DDR type zeolite layer deposited within pores of substrate exceeds 50 times of the mean pore diameter, pressure loss becomes excessive,
10 and thus when the obtained DDR type zeolite membrane composite is used as a gas separation membrane, a sufficient flux cannot be secured. Further, depositing a DDR type zeolite within the pores of the porous substrate takes too much time.

15 In this embodiment, the thickness of a DDR type zeolite layer deposited outside of the substrate disposed on the surface of a porous substrate is 30 μm or less, but is more preferably 10 μm or less. When a DDR type zeolite membrane composite includes a DDR type zeolite layer deposited within
20 pores of substrate with a sufficient thickness, a DDR type zeolite layer deposited outside of the substrate is not necessarily required. If the thickness of a DDR type zeolite layer deposited outside of the substrate exceeds 30 μm , defects such as cracks due to thermal stress may increase
25 in a heat treatment processing or the like of a DDR type zeolite membrane.

The thickness of the porous substrate used in the embodiment is not limited.

The hydrothermal synthesis in forming a DDR type zeolite is generally performed at 130 to 200°C, but hydrothermal
5 synthesis at 140°C to 180°C is preferable in order to easily form a DDR type zeolite layer deposited within pores of substrate, within the pores of the porous substrate. Besides the hydrothermal synthesis temperature, one may control also the thickness of a DDR type zeolite layer deposited outside
10 of the substrate and the thickness of the DDR type zeolite layer deposited within pores of substrate by controlling the composition of a raw material solution, or synthesizing time.

In this embodiment, one may use a raw material solution that further contains a DDR type zeolite powder to be a seed
15 crystal as a raw material solution. A DDR type zeolite powder assists the formation of a DDR type zeolite membrane. A general stirring method may be used as a method for dispersing a DDR type zeolite powder in a raw material solution, but other methods such as ultrasonic treatment may be used, and
20 uniform dispersion allows a denser DDR type zeolite membrane with a uniform thickness to be formed.

In this embodiment, a DDR type zeolite powder to be a seed crystal is deposited on a surface of a porous substrate to be immersed in a raw material solution, instead of
25 dispersing a DDR type zeolite powder to be a seed crystal in a raw material solution. One may form a DDR type zeolite

membrane having a more dense and uniform thickness in a short time with the employment of such a constitution.

"Depositing a DDR type zeolite powder on a porous substrate" refers to a state where a DDR type zeolite powder to be a seed crystal is disposed on a surface of the porous substrate on which a DDR type zeolite membrane is to be formed, but a firm adhesion is not necessarily required. In order to deposit a DDR type zeolite powder on the porous substrate, for example, a DDR type zeolite powder may be dispersed in water to prepare a dispersion solution with an appropriate concentration, and an appropriate amount of dispersion solution may be applied to the surface of the porous substrate on which a DDR type zeolite membrane is to be formed. One may select, as an application method, any method among the dropping method, dipping method, spin coating method, printing method, or the like depending on purposes.

Examples

Now, examples of the present invention (the first aspect of the present invention) will be described in detail, but the present invention (the first aspect of the present invention) is not limited to these examples.

(Production of DDR type zeolite powder (seed crystal))

In accordance with a production method of a DDR type zeolite described in M. J. den Exter, J. C. Jansen, H. van Bekkum, Studies in Surface Science and Catalysis vol. 84, Ed. by J. Weitkamp et al., Elsevier (1994) 1159-1166, a DDR

type zeolite powder with a particle diameter of about 100 μm was produced. This powder was ground into fine powder with a particle diameter of 5 μm or less and used as a seed crystal.

(Example 1)

5 A jar of 100 ml capacity made of fluororesin was charged with 1.80 g of ethylenediamine (produced by Wako Pure Chemical Industries, Ltd.), and then 0.57 g of 1-adamantanamine (produced by Katayama Chemical Industries Co., Ltd.) was added and dissolved so as not to leave precipitation
10 of 1-adamantanamine. Another beaker was charged with 73.45 g of water, were added thereto 3.0 g of 30 % by mass of silica sol (Snowtex S, produced by Nissan Chemical Industries, Ltd.), and the resultant was gently stirred, and then added to the jar containing mixed ethylenediamine and 1-adamantanamine,
15 and the resultant was vigorously shaken to prepare a raw material solution. At this time, the 1-adamantanamine/ SiO_2 ratio was 0.25, the water/ SiO_2 ratio was 280, and the ethylenediamine/1-adamantanamine ratio was 8.

 The jar containing a raw material solution was placed
20 in a shaker, and further shaken at 500 rpm for one hour. Then, 0.1 mg of a DDR type zeolite powder obtained by the production method of a DDR type zeolite powder was added as a seed crystal, and ultrasonically treated at 65°C for 5 minutes to make it dispersed. Then, the raw material solution in which a DDR
25 type zeolite powder was dispersed was transferred to a pressure resistant vessel of 100 ml capacity made of stainless with an internal cylinder made of fluororesin, a

disk made of fluororesin having 35 mm ϕ diameter \times 10 mm thickness to be a support base for membrane forming was placed on a bottom of the vessel, and subjected to heat treatment (hydrothermal synthesis) at 160°C for 5 days. After the heat treatment, the disk made of fluororesin was taken out to find that a self-supported membrane was formed on the disk. The membrane was delaminated from the disk, rinsed, dried, and then heated to 800°C with increasing temperature at a speed of 0.1°C/min in an electric furnace in the air, and kept for 4 hours at that temperature, then cooled to room temperature at a speed of 1°C/min.

Next, a crystal phase of thus obtained membrane was examined by X-ray diffraction to evaluate the crystal phase, and a diffraction peak only of a DDR type zeolite was detected. The crystal phase was observed with an electron microscope to find that the membrane was 75 μ m thick and made of polycrystal, and to confirm that the membrane was a self-supported membrane of DDR type zeolite.

"Diffraction peak of a DDR type zeolite" in the X-ray diffraction is a diffraction peak described in International Center for Diffraction Data (ICDD) "Powder Diffraction File" No. 38-651 or 41-571 corresponding to Deca-Dodecasil 3R. The crystal phase of thus formed zeolite was evaluated as "amorphous" in the case that when only broad halo but no clear peak were observed, that of the one was "still under the crystallization" in the case that when even a few peaks were observed, and that of the one was "complete crystal" in the

case that sharp peaks of a DDR type zeolite with no halo was observed in the x-ray diffraction in a range of 20 to 30° (CuK α). .

(Examples 2 to 12, Comparative Examples 1 to 3).

5 The formation of DDR type zeolite membranes was performed by repeating the operations similar to those of Example 1 except that composition ratios in the raw material solution and heat treatment conditions were altered. The obtained membranes were evaluated by X-ray diffraction in
10 the same manner as in Example 1, and a thickness of them was measured by observation with the electron microscope. The composition ratios of the raw material solution (the 1-adamantanamine/SiO₂ ratios, the water/SiO₂ ratios, and the ethylenediamine/1-adamantanamine ratios), the heat
15 treatment conditions (temperature, time), and the thicknesses of the formed DDR type zeolite membrane are shown in Table 1.

(Comparative Example 4)

20 The formation of a DDR type zeolite membrane was performed by repeating the operations similar to those of Example 1 except that DDR type zeolite powder to be a seed crystal was not used. As a result, a DDR type zeolite powder was produced, but no DDR type zeolite membrane was formed (Table 1). In Table 1, a case of using the seed crystal (DDR
25 type zeolite powder) was indicated as "present", and a case of using no seed crystal was indicated as "absent".

[Table 1]

	1-adamantanamine/ SiO ₂ ratio (molar ratio)	Water/SiO ₂ ratio (molar ratio)	Ethylenediamine/ 1-adamantanamine ratio (molar ratio)	Seed crystal	Heat treatment temperature (°C)	Heat treatment time (day)	Thickness of DDR type zeolite membrane (μm)
Example 1	0.25	280	8	Present	160	5	75
Example 2	0.1	50	8	Present	160	5	110
Example 3	0.1	500	8	Present	160	5	80
Example 4	0.4	500	8	Present	160	5	100
Example 5	0.4	50	8	Present	160	5	90
Example 6	0.05	70	8	Present	160	10	120
Example 7	0.12	140	10	Present	160	5	80
Example 8	0.12	280	10	Present	200	1	50
Example 9	0.12	280	5	Present	200	1	40
Example 10	0.25	280	8	Present	150	5	60
Example 11	0.25	200	8	Present	180	2	70
Example 12	0.35	200	8	Present	130	10	50
Comparative Example 1	0.25	200	8	Present	100	10	No membrane formed
Comparative Example 2	0.12	280	8	Present	220	5	DOH phase formed
Comparative Example 3	0.12	300	3	Present	160	5	No membrane formed
Comparative Example 4	0.25	280	8	Absent	160	5	No membrane formed

(Example 13)

The formation of DDR type zeolite membranes was performed by repeating the operations similar to those of Example 1 except that 1.50 g of ethylenediamine, 0.47 g of 1-adamantanamine, 2.50 g of 30 % by mass of silica sol, and 48.70 g of water were used to prepare a raw material solution. At this time, the 1-adamantanamine/SiO₂ ratio was 0.25, the water/SiO₂ ratio was 220, and the ethylenediamine/1-adamantanamine ratio was 8.

10 A disk-like substrate of 15 mmφ diameter × 1.5 mm thickness was prepared as a porous substrate by machining an alumina porous substrate having a mean pore diameter of 0.6 μm (produced by NGK Insulators, Ltd.). A DDR type zeolite powder obtained by the above-mentioned production method of
15 a DDR type zeolite powder was used as a seed crystal and added to water to prepare a dispersion solution having a concentration of 1 mg/ml, and one drop of this solution was applied to one surface of the porous substrate. The porous substrate was vertically set up in a pressure resistant
20 vessel of 100 ml capacity made of stainless with an internal cylinder made of fluororesin, and immersed in the raw material solution. The pressure resistant vessel was placed in a drier having a shaking device with an internal temperature adjusted at 150°C, and subjected to heat
25 treatment (hydrothermal synthesis) for 5 days with the pressure resistant vessel shaken at 90 times/min. After the heat treatment, the porous substrate was taken out to find

that a membrane was formed on the porous substrate. The porous substrate was rinsed, dried, and then heated to 800°C with increasing temperature at a speed of 0.1°C/min in an electric furnace in the air, and kept for 4 hours at that
5 temperature, then cooled to room temperature at a speed of 1°C/min.

Next, a crystal phase of the obtained membrane on the porous substrate was examined by X-ray diffraction to evaluate the crystal phase, and diffraction peaks of a DDR
10 type zeolite and the porous substrate were detected to find that the membrane was a DDR type zeolite membrane. The membrane was observed with an electron microscope to find that a 10 μm thick dense membrane was formed on the porous substrate, and to confirm that a DDR type zeolite membrane
15 can be formed on the porous substrate. Figures 1 and 2 show electron microphotographs of crystal structures of a DDR type zeolite membrane produced in Example 13, and Figure 1 shows a crystal structure on a cross section, and Figure 2 shows a crystal structure on a surface of the membrane.

20 (Examples 14 to 26)

The formation of DDR type zeolite membranes on a porous substrate was performed by repeating the operations similar to those of Example 13 except that composition ratios in the raw material solution and heat treatment conditions were
25 altered. The formed membranes were evaluated by X-ray diffraction the same as in Example 13, and a thickness was measured by observation with an electron microscope. The

composition ratios of the raw material solution (the 1-adamantanamine/SiO₂ ratio, the water/SiO₂ ratio, and the ethylenediamine/1-adamantanamine ratio), the heat treatment conditions (temperature, time), and the thicknesses of the
5 formed DDR type zeolite membrane are shown in Table 2.

[Table 2]

	1-adamantanamine/ SiO ₂ ratio (molar ratio)	Water/SiO ₂ ratio (molar ratio)	Ethylenediamine/ 1-adamantanamine ratio (molar ratio)	Heat treatment temperature (°C)	Heat treatment time (day)	Thickness of DDR type zeolite membrane (μm)
Example 13	0.25	220	8	150	5	10
Example 14	0.25	160	8	160	10	33
Example 15	0.4	220	5	160	5	25
Example 16	0.12	100	5	150	5	14
Example 17	0.31	280	8	150	5	11
Example 18	0.2	220	8	150	5	8
Example 19	0.25	340	10	150	5	12
Example 20	0.4	50	10	150	10	50
Example 21	0.25	280	8	150	10	20
Example 22	0.15	200	8	160	10	18
Example 23	0.12	50	8	160	5	22
Example 24	0.05	50	8	160	5	21
Example 25	0.05	500	5	180	5	18
Example 26	0.25	340	8	180	10	45

(Example 27)

The formation of DDR type zeolite membrane on a porous substrate was performed by repeating the operations similar to those of Example 13 except that the pressure resistant vessel was not shaken. As a result, it was found that a 5 μm thick DDR type zeolite membrane was formed on the porous substrate.

(Example 28)

The formation of DDR type zeolite membrane on a porous substrate was performed by repeating the operations similar to those of Example 13 except that a dispersion solution containing a DDR type zeolite powder was not applied to one surface of the porous substrate, but a seed crystal was dispersed in the raw material solution according to operations similar to Example 1. As a result, it was found that an 8 μm thick DDR type zeolite membrane was formed on a porous substrate.

(Examples 29 to 36)

Raw materials were mixed to have composition ratios (the 1-adamantanamine/ SiO_2 ratio, the water/ SiO_2 ratio, and the ethylenediamine/1-adamantanamine ratio) shown in Table 3 to prepare a raw material solution. A porous substrate was prepared that was an alumina porous body (produced by NGK Insulators, Ltd.) having a mean pore diameter of 0.6 μm machined to be a cylinder (17 mm ϕ outer diameter \cdot 12 mm ϕ inner diameter \times 40 mm length). A DDR type zeolite powder obtained by the above-mentioned production method of a DDR type

zeolite powder was used as a seed crystal, and added to water to prepare a dispersion solution with a concentration of 1 mg/ml, and the porous substrate was dipped in the dispersion solution, and then dried at 80°C, and a DDR type zeolite powder
5 was deposited on a surface of the porous substrate.

The porous substrate was vertically set up in a pressure resistant vessel of 100 ml capacity made of stainless with an internal cylinder made of fluororesin, and immersed in the raw material solution, and vacuum degassing treatment
10 was performed to impregnate pores of the porous substrate with the raw material solution. Then, hydrothermal synthesis was performed under the heat treatment condition shown in Table 3 to form a DDR type zeolite membrane on the porous substrate. The formed membrane was evaluated by X-ray
15 diffraction the same as in Example 13, and a thickness was measured by observation with an electron microscope. The composition ratios of the raw material solution, the heat treatment conditions (temperature, time), and the thicknesses of the formed DDR type zeolite membrane are shown
20 in Table 3.

[Table 3]

	1-adamantanamine/ SiO ₂ ratio (molar ratio)	Water/SiO ₂ ratio (molar ratio)	Ethylenediamine/ 1-adamantanamine ratio (molar ratio)	Heat treatment temperature (°C)	Heat treatment time (day)	Thickness of DDR type zeolite membrane (μm)
Example 29	0.12	56	16	160	2	7
Example 30	0.06	28	16	160	2	10
Example 31	0.25	112	24	160	2	3
Example 32	0.12	56	16	140	5	8
Example 33	0.1	56	16	170	5	16
Example 34	0.04	25	28	160	3	9
Example 35	0.25	112	32	160	5	10
Example 36	0.03	20	16	155	2	7

(Gas permeation test (1))

A gas permeation test was conducted using a DDR type zeolite membrane produced in Example 1. Figure 3 schematically illustrates a configuration of a gas permeation test apparatus used in the gas permeation test, and shows a state where a shaped DDR type zeolite membrane 102 was attached to a tip of a measuring tube 101 (15 mmφ inner diameter) made of zirconia, and this was placed in a core tube 104 (25 mmφ inner diameter) of a tubular furnace 103, and a quartz tube 105 of 6 mmφ inner diameter was inserted into the measuring tube 101 to near a DDR type zeolite membrane 102 to provide a triple tube structure. Xylene containing isomers of ortho, para, and meta mixed in an equimolar amount was introduced as a test gas into the outside of the measuring tube 101 (inside the core tube 104) while bubbling nitrogen gas (50 ml/min) at room temperature, and a nitrogen gas (sweep gas, 50 ml/min) for recovering a gas having permeated a DDR type zeolite membrane 102 was flown into the quartz tube 105 inside the measuring tube 101. In this state, the tubular furnace 103 was heated to a test temperature (100°C), and kept for one hour or more to reach a steady state. The sampling gas of the recovery gas containing the gas having permeated a DDR type zeolite membrane 102 was taken, and analyzed with a gas chromatograph to evaluate a xylene gas permeance ($\text{nmol}\cdot\text{m}^{-2}\cdot\text{s}^{-1}\cdot\text{Pa}^{-1}$).

Besides xylene, methane (CH_4) and carbon dioxide (CO_2) were used for permeation tests. These test gases were in

gaseous form at room temperature, and thus was directly introduced into a gas inlet 113 of the core tube 104. The test results will be shown in Table 4 and Figure 4.

5 [Table 4]

Test gas	Permeance ($\text{nmol}\cdot\text{m}^{-2}\cdot\text{s}^{-1}\cdot\text{Pa}^{-1}$)
Xylene	2
CH_4	10
CO_2	226

(Mixed gas permeation test)

For a DDR type zeolite membrane produced in Example 1, a gas permeation test was carried out on a mixed gas of four
 10 kind gases of methane (CH_4), ethyl mercaptan ($\text{C}_2\text{H}_5\text{SH}$), dimethyl sulfide ($(\text{CH}_3)_2\text{S}$), and tertiary butyl mercaptan ($(\text{CH}_3)_3\text{CSH}$) (mainly containing methane with other components of 1000 ppm), using a gas permeation test apparatus 110 shown in Figure 3 and by operations similar to the above described
 15 "gas permeation test (1)". A test temperature was 200°C . The test results are shown in Table 5 and Figure 5.

[Table 5]

Test gas	Permeation gas	Permeance ($\text{nmol}\cdot\text{m}^{-2}\cdot\text{s}^{-1}\cdot\text{Pa}^{-1}$)
$\text{CH}_4/\text{C}_2\text{H}_5\text{SH}/(\text{CH}_3)_2\text{S}/(\text{CH}_3)_3\text{CSH}$ Mixed gas	CH_4	5.2
	$\text{C}_2\text{H}_5\text{SH}$	7.3
	$(\text{CH}_3)_2\text{S}$	1.4
	$(\text{CH}_3)_3\text{CSH}$	1.1

(Gas permeation test (2))

For a DDR type zeolite membrane produced in Example 29, a gas permeation test was carried out using the gas permeation test apparatus shown in Figure 3 similarly to the above described "gas permeation test (1)". A cylindrical DDR type zeolite membrane 102 with one opening end closed by an alumina plate was attached to a tip of a measuring tube 101 (17 mm ϕ outer diameter, 13 mm ϕ inner diameter) made of alumina. This was placed in a core tube 104 (25 mm ϕ inner diameter) of a tubular furnace 103, and a quartz tube 105 of 6 mm ϕ outer diameter and 4 mm ϕ inner diameter was inserted into the measuring tube 101 to near the DDR type zeolite membrane 102 to provide a triple tube structure. A test gas (100 ml/min) containing methane and carbon dioxide mixed in an equimolar amount was introduced outside the measuring tube 101 (inside the core tube) through a gas inlet 113, and helium gas (sweep gas, 200 ml/min) for recovering a gas having permeated the DDR type zeolite membrane 102 was flown into the quartz tube 105 inside the measuring tube 101. In this state, the tubular furnace 103 was heated to a test temperature (100°C), and kept for one hour or more to reach a steady state. The sampling gas of the recovery gas containing the gas having permeated the DDR type zeolite membrane 102 was taken, and analyzed with a gas chromatograph to evaluate permeances (nmol \cdot m $^{-2}\cdot$ s $^{-1}\cdot$ Pa $^{-1}$) of methane and carbon dioxide and to calculate a separation factor (carbon dioxide/methane). The separation factor of carbon dioxide/methane was 90.

(Discussion)

It was found, as is clear from the results shown in Tables 1 to 3, that a DDR type zeolite membrane having a sufficient thickness as a self-support membrane can be produced by
5 adjusting the 1-adamantanamine/SiO₂ ratio within 0.03 to 0.4, and the ethylenediamine/1-adamantanamine ratio within 5 to 32. A DDR type zeolite membrane can be formed by adjusting the water/SiO₂ ratio within 20 to 500. It was also found that a DDR type zeolite membrane can be formed on the porous
10 substrate.

For the heat treatment conditions in the hydrothermal synthesis, a DDR type zeolite membrane having a sufficient thickness can be produced at 130°C to 200°C in a short period such as within 10 days.

15 It can be taken, as is clear from the results shown in Tables 3, that even if the porous substrate is cylindrical, a DDR type zeolite membrane can be formed on a surface thereof. Further, it was found that a DDR type zeolite membrane has a good separation capability of a mixed gas of carbon
20 dioxide/methane (a separation factor of carbon dioxide/methane = 90).

It was found, as is clear from the results shown in Tables 4 and Figure 4, that xylene hardly permeated a DDR type zeolite membrane, but carbon dioxide and methane permeated, and
25 carbon dioxide showed a permeation of about 20 times higher than that of methane. This may depends on pore diameter of

a DDR type zeolite membrane and a molecule diameter of the test gas.

It was found, as is clear from the results shown in Tables 5 and Figure 5, that dimethyl sulfide and tertiary butyl mercaptan having a relatively large molecule diameter, compared to methane and ethyl mercaptan having a relatively small molecule diameter, have low permeation. That is, the obtained DDR type zeolite membrane has a good separation capability of dimethyl sulfide and tertiary butyl mercaptan from methane, and thus can be used for separation of, for example, a mixed gas of dimethyl sulfide and methane, or a mixed gas of tertiary butyl mercaptan and methane.

Therefore, from the results of the gas permeation test and the mixed gas permeation test, a molecular sieving action of a DDR type zeolite membrane produced by the production method according to the present invention (the first aspect of the present invention) and its availability (gas separation property) could be confirmed.

Now, examples of the present invention (the second aspect of the present invention) will be described in detail, but the present invention (the second aspect of the present invention) is not limited to the examples.

(Example 37)

A jar of 100 ml capacity made of fluororesin was charged with ethylenediamine (produced by Wako Pure Chemical Industries, Ltd.), and then 1-adamantanamine (produced by

Katayama Chemical Industries Co., Ltd.) was added to dissolve 1-adamantanamine thoroughly. Another beaker was charged with ion-exchanged water, 30 % by mass of silica sol (produced by Nissan Chemical Industries, Ltd., trade name: Snowtex S) 5 was added and gently stirred, and then added to the above described jar and the resultant was vigorously shaken to prepare a raw material solution. At this time, the 1-adamantanamine/SiO₂ ratio (molar ratio) was 0.0625, the water/SiO₂ ratio (molar ratio) was 42, and the 10 ethylenediamine/1-adamantanamine ratio (molar ratio) was 16. The jar containing the raw material solution was placed in a shaker, and further shaken at 500 rpm for one hour.

A disk-like porous substrate of 15 mmφ diameter × 1.5 mm thickness was prepared as a porous substrate by machining 15 an alumina porous substrate having a mean pore diameter of 0.6 μm (produced by NGK Insulators, Ltd.). A dispersion solution in which a DDR type zeolite powder is dispersed in the ion-exchanged water was prepared, and applied to one surface of the porous substrate.

20 The porous substrate was vertically set up in a pressure resistant vessel of 100 ml capacity made of stainless with an internal cylinder made of fluororesin, and immersed in the raw material solution. The pressure resistant vessel was placed in a drying oven having an internal temperature 25 adjusted at 160°C, and subjected to heat treatment (hydrothermal synthesis) for 46 hours.

After the heat treatment, the porous substrate was taken out to find that a membrane was formed on the porous substrate. The porous substrate was rinsed, dried, and then heated to 800°C with increasing temperature at a speed of 0.1°C/min in an electric furnace in the air, and kept for 4 hours at that temperature, then cooled to room temperature at a speed of 1°C/min.

Next, a crystal phase of a membrane on the obtained porous substrate was examined by X-ray diffraction to evaluate the crystal phase, and diffraction peaks of a DDR type zeolite and the porous substrate were detected to find that the membrane was a DDR type zeolite membrane. The membrane was observed with an electron microscope to find that a 5 μm thick dense membrane was formed on the porous substrate.

(Single gas permeation test)

A gas permeation test was conducted using a DDR type zeolite membrane produced in Example 37. Figure 7 schematically illustrates a configuration of a gas permeation test apparatus 260 used in the gas permeation test, and shows a state where a DDR type zeolite membrane produced in Example 37 and formed on the porous substrate was attached to a tip of a measuring tube 251 (15 mm ϕ outer diameter) made of alumina, and this was placed in a core tube 254 (25 mm ϕ inner diameter) of a tubular furnace 253, and a quartz tube 255 of 6 mm ϕ inner diameter was inserted into the measuring tube 251 to near the DDR type zeolite membrane 252 to provide

a triple tube structure. A test gas was introduced into the outside of the measuring tube 251 (the inside of the core tube 254), and nitrogen gas (sweep gas) for recovering a gas having permeated the DDR type zeolite membrane 252 was flown into the quartz tube 255 inside the measuring tube 251. In this state, a temperature in the tubular furnace was adjusted to a predetermined degree, and kept for one hour or more to reach a steady state. The sampling gas of the recovery gas containing the gas having permeated the DDR type zeolite membrane 252 was taken, and analyzed with a gas chromatograph to evaluate a permeance ($\text{mol}\cdot\text{m}^{-2}\cdot\text{s}^{-1}\cdot\text{Pa}^{-1}$) of the gas having permeated the membrane. The test results are shown in Tables 6 and 7. In Table 7, values of ratios of "single gas permeances of gas components described in A (CO_2 , H_2 , O_2 , N_2 , CH_4 , $n\text{-C}_4\text{H}_{10}$, $i\text{-C}_4\text{H}_{10}$)" to "single gas permeances of gas components described in B (H_2 , O_2 , N_2 , CH_4 , $n\text{-C}_4\text{H}_{10}$, $i\text{-C}_4\text{H}_{10}$, SF_6)" are indicated. A top in each cell shows a value at room temperature (26°C), and a bottom shows a value at 100°C .

[Table 6]

(Unit: $10^{-9} \text{ mol}\cdot\text{m}^{-2}\cdot\text{s}^{-1}\cdot\text{Pa}^{-1}$)

Gas type	Temperature	
	26°C	100°C
CO_2	48	18.7
H_2	7.8	6.6
O_2	2.8	1.6
N_2	2.2	1.4
CH_4	0.054	0.060
$n\text{-C}_4\text{H}_{10}$	0.0033	0.0036
$i\text{-C}_4\text{H}_{10}$	0.0027	0.0028
SF_6	0.0022	0.0021

[Table 7]

Single gas permeance ratio (A/B)

A \ B	H ₂	O ₂	N ₂	CH ₄	n-C ₄ H ₁₀	i-C ₄ H ₁₀	SF ₆
CO ₂	6.2 2.8	17 12	22 13	890 310	15000 5200	18000 6700	22000 8900
H ₂		2.8 4.1	3.5 4.7	140 110	2400 1800	2900 2400	3500 3100
O ₂			1.3 1.1	52 27	850 440	1000 570	1300 760
N ₂				41 23	670 390	820 500	1000 670
CH ₄					16 17	20 21	25 29
n-C ₄ H ₁₀						1.2 1.7	1.5 1.7
i-C ₄ H ₁₀							1.2 1.3

Top: 26°C, Bottom: 100°C

5

(Mixed gas permeation test)

A gas permeation test was conducted on mixed gases (equimolar mixed gases) shown in Table 8 as test gases, using the gas permeation test apparatus 260 shown in Figure 7 and
 10 by operations similar to the above described single gas permeation test. The test results are shown in Table 8.

[Table 8]

Equimolar mixed gas	Separation factor	
	26°C	100°C
CO ₂ /CH ₄	670	340
H ₂ /CH ₄	130	94
C ₂ H ₄ /C ₂ H ₆	5.8	3.3

15

(Air permeation test)

An air permeation test was conducted using the gas permeation test apparatus 260 shown in Figure 7 and by operations similar to the above described single gas permeation test. The test results will be shown in Table 9. A separation factor α of O_2/N_2 was calculated by an equation (2) from a gas flux obtained by the air permeation test.

$$\alpha = (Q_A/Q_B)/(P_A/P_B) \dots (2)$$

wherein Q_A and Q_B are fluxes ($\text{mol}\cdot\text{m}^{-2}\cdot\text{s}^{-1}$) of a gas A and a gas B, P_A and P_B are partial pressures (Pa) in the test gases A and B. In this air permeation test, the gas A is oxygen, and the gas B is nitrogen.

That is, the separation factor was calculated from each value of a ratio of a gas flux of O_2 at room temperature and 100°C to a gas flux of N_2 at room temperature and 100°C, when the air permeates a DDR type zeolite membrane, divided by a value (1/4) of a ratio of a partial pressure of O_2 to a partial pressure of N_2 in the air, respectively.

[Table 9]

O_2/N_2	Separation factor	
	26°C	100°C
	1.8	1.6

It was found that, according to a DDR type zeolite membrane of the present invention, one or more types of particular gas components can be separated from a mixed gas containing two or more types of particular gas components, since it has different single gas permeances respectively

as to at least two types of gases selected from a group consisting of a plurality of particular gases.

Now, examples of the present invention (the third aspect
5 of the present invention) will be described in detail, but the present invention (the third aspect of the present invention) is not limited to the examples.

(Production of DDR type zeolite powder (seed crystal))

In accordance with a production method of DDR type
10 zeolite described in M. J. den Exter, J. C. Jansen, H. van Bekkum, Studies in Surface Science and Catalysis vol. 84, Ed. by J. Weitkamp et al., Elsevier (1994) 1159-1166, a DDR type zeolite powder with a crystal size of about 100 μm was produced. This powder was ground into fine powder with a size
15 of 5 μm or less and used as a seed crystal.

(Example 38)

A jar of 100 ml capacity made of fluororesin was charged with 6.01 g of ethylenediamine (produced by Wako Pure Chemical Industries, Ltd.), and then 0.95 g of 1-
20 adamantanamine (produced by Katayama Chemical Industries Co., Ltd.) was added and dissolved so as not to leave precipitation of 1-adamantanamine. Another beaker was charged with 43.41 g of water, 10.01 g of 30 % by mass of silica sol (produced by Nissan Chemical Industries, Ltd., trade name: Snowtex S)
25 of were added and gently stirred, and then added to the jar containing mixed ethylenediamine and 1-adamantanamine, and the resultant was vigorously shaken to prepare a raw material

solution. At this time, the mixing ratio of 1-adamantanamine to silica (1-adamantanamine (mol)/SiO₂ (mol)) was 0.125, the mixing ratio of water to silica (water (mol)/SiO₂ (mol)) was 56, and the mixing ratio of ethylenediamine to 1-
5 adamantanamine (ethylenediamine (mol)/1-adamantanamine (mol)) was 16.

A disk-like substrate of 15 mm ϕ diameter \times 1.5 mm thickness was prepared as a porous substrate by machining an alumina porous substrate having a mean pore diameter of
10 0.6 μ m (produced by NGK Insulators, Ltd.). A DDR type zeolite powder was used as a seed crystal, and added to water to prepare a dispersion solution with a concentration of 1 mg/ml, and the dispersion solution was applied to one surface of the porous substrate. The porous substrate was vertically
15 set up in a pressure resistant vessel of 100 ml capacity made of stainless with an internal cylinder made of fluororesin, and immersed in the raw material solution. The pressure resistant vessel was placed in a drying oven having an internal temperature adjusted at 160°C, and subjected to
20 hydrothermal synthesis for 48 hours to form a DDR type zeolite membrane composite having a zeolite layer deposited outside of the substrate formed on a surface of the porous substrate, and having a zeolite layer deposited within pores of substrate formed within the pores of the surface of the porous
25 substrate on which a DDR type zeolite layer deposited outside of the substrate is disposed.

After the hydrothermal synthesis, a DDR type zeolite membrane composite was rinsed, dried, and then heated to 800°C with increasing temperature at a speed of 0.1°C/min in an electric furnace in the air, and kept for 4 hours at that
5 temperature, then cooled to room temperature at a speed of 1°C/min to form a DDR type zeolite membrane composite having no organic molecule as a structure-directing agent.

Next, a crystal phase of a zeolite membrane on the porous substrate that constitutes the obtained DDR type zeolite
-10- membrane composite was examined by X-ray diffraction to evaluate the crystal phase, and diffraction peaks of a DDR type zeolite and the porous substrate were detected to find that the zeolite membrane disposed on the porous substrate was a DDR type zeolite membrane.

15 "Diffraction peak of a DDR type zeolite" in the X-ray diffraction is a diffraction peak described in International Center for Diffraction Data (ICDD) "Powder Diffraction File" No. 38-651 or 41-571 corresponding to Deca-Dodecasil 3R. The membrane was observed with an electron microscope to find
20 that a 7 μm thick dense DDR type zeolite layer deposited outside of the substrate was formed on the porous substrate. A 6 μm thick DDR type zeolite layer deposited within pores of substrate made of a DDR type zeolite was formed within pores of a surface of the porous substrate on which a DDR
25 type zeolite layer deposited outside of the substrate was formed. Figures 9 and 10 are electron microphotographs of shapes of a DDR type zeolite membrane composite produced in

Example 38, and Figure 9 shows a shape on a cross section of a DDR type zeolite membrane composite, and Figure 10 shows a shape on a surface of a DDR type zeolite membrane composite.

(Examples 39 to 48, Comparative Examples 5 to 9)

5 The formation of a DDR type zeolite membranes composite was preformed by repeating operations similar to those of Example 38 except that composition ratios of the raw material solution, amounts of the raw material solution, heat treatment conditions, and shapes of the porous substrate were
10 altered. A porous substrate in the form of a disk used in Example 38 and a porous substrate machined to be a tube of 17 mm ϕ outer diameter \times 2.5 mm thickness were prepared as a porous substrate. The formed DDR type zeolite membrane was evaluated by X-ray diffraction the same as in Example 38,
15 and the thickness of a DDR type zeolite layer deposited within pores of substrate and the thickness of a DDR type zeolite layer deposited outside of the substrate were measured by observation with an electron microscope. The composition ratios of the raw material solution (1-adamantanamine
20 (mol)/silica (mol), ethylenediamine (mol)/silica (mol), and ethylenediamine (mol)/1-adamantanamine (mol)), the substrate shapes, the heat treatment conditions (temperature, time), and the thicknesses of the formed DDR type zeolite layer deposited outside of the substrate, and the thicknesses
25 of a DDR type zeolite layer deposited within pores of substrate are shown in Table 10.

[Table 10]

	1- adamtan- amine/ silica (molar ratio)	Ethylene- diamine/ 1- adamtan- amine (molar ratio)	Water/ silica (molar ratio)	Hydrothermal synthesis temperature (°C)	Hydrothermal synthesis time (hour)	Shape of porous substrate	Mean pore diameter of porous substrate (μm)	Thickness of DDR type zeolite layer deposited outside of the substrate (μm)	Thickness of DDR type zeolite layer deposited within the pores of substrate (μm)	Separation factor of CO_2/CH_4 at 100°C
Example 38	0.125	16	56	160	48	Disk	0.6	7	6	226
Example 39	0.0625	16	28	160	48	Disk	0.6	10	5	174
Example 40	0.25	16	112	160	48	Disk	0.6	5	3	46
Example 41	0.0625	16	56	160	48	Disk	0.6	5	3	132
Example 42	0.25	32	112	160	72	Disk	0.6	3	3	66
Example 43	0.25	16	224	160	72	Disk	0.6	5	5	59
Example 44	0.5	16	224	160	72	Disk	0.6	7	6	383
Example 45	0.125	16	56	160	72	Tube	0.6	9	5	78
Example 46	0.125	16	56	160	72	Tube	0.6	10	5	57
Example 47	0.25	8	112	160	48	Disk	0.6	13	3	4
Example 48	0.125	16	112	160	48	Disk	0.6	5	3	3
Comp. Example 5	0.25	16	224	160	48	Disk	0.6	2	2	1
Comp. Example 6	0.5	16	224	160	48	Disk	0.6	3	2	1
Comp. Example 7	0.25	32	112	160	48	Disk	0.6	No membrane formed	0	1
Comp. Example 8	0.25	32	224	160	72	Tube	0.6	5	2	3
Comp. Example 9	0.25	32	224	160	72	Tube	0.6	5	2	1

(Gas permeation test)

A gas permeation test was conducted using the DDR type zeolite membrane composites produced in Examples 39 to 48, and Comparative Examples 5 to 9.

5 Figure 11 schematically illustrates a configuration of a gas permeation test apparatus 320 used in a gas permeation test, and shows a state where a DDR type zeolite membrane composite 312 was attached to a tip of a measuring tube 311 (15 mm ϕ inner diameter) made of alumina, and this was placed
10 in a core tube 314 (25 mm ϕ inner diameter) of a tubular furnace 313, and a quartz tube 315 of 6 mm ϕ inner diameter was inserted into the measuring tube 311 to near the DDR type zeolite membrane composite 312 to provide a triple tube structure. A mixed gas of methane (CH_4) and carbon dioxide (CO_2) was
15 directly introduced into the core tube 314 of the gas permeation test apparatus thus configured through a gas inlet 323 that can be divided by the core tube 314 and a valve 322. A feeding speed of the mixed gas was 50 ml/min when the porous substrate was in the form of a disk, and 100 ml/min when the
20 porous substrate was in the form of a tube.

 Helium gas (sweep gas; 100 ml/min for the disk substrate, and 200 ml/min for the tube substrate) for recovering a gas having permeated the DDR type zeolite membrane composite 312 was flown into the quartz tube 315 inside the measuring tube
25 311. In this state, the tubular furnace 313 was heated to a test temperature (100°C), and kept for one hour or more to reach a steady state. The sampling gas of the recovery gas

containing the gas having permeated the DDR type zeolite membrane composite 312 was taken, and analyzed with a gas chromatograph to evaluate permeances of methane and carbon dioxide ($\text{nmol}\cdot\text{m}^{-2}\cdot\text{s}^{-1}\cdot\text{Pa}^{-1}$). A separation factor of CO_2/CH_4 at 5 100°C will be shown in Table 10. A separation factor α of CO_2/CH_4 was calculated by an equation (3).

$$\alpha = (Q_{\text{A}}/Q_{\text{B}})/(P_{\text{A}}/P_{\text{B}}) \dots (3)$$

In the equation (3), Q_{A} is a permeance ($\text{nmol}\cdot\text{m}^{-2}\cdot\text{s}^{-1}\cdot\text{Pa}^{-1}$) of CO_2 , Q_{B} is a permeance ($\text{nmol}\cdot\text{m}^{-2}\cdot\text{s}^{-1}\cdot\text{Pa}^{-1}$) of CH_4 , P_{A} 10 is a partial pressure (Pa) of CO_2 in the test gas, and P_{B} is a partial pressure (Pa) of CH_4 in the test gas.

(Discussion)

As is clear from the results shown in Table 10, one may form a DDR type zeolite membrane composite comprising a DDR 15 type zeolite layer deposited within pores of substrate having a thickness 5 times ($3\text{ }\mu\text{m}$) or more of the mean pore diameter ($0.6\text{ }\mu\text{m}$) of the porous substrate used in this embodiments, a CO_2/CH_4 separation factor of 2 or more at 100°C, and usable as a gas separation membrane by adjusting the mixing ratio 20 of 1-adamantanamine to silica within 0.03 to 0.5, the mixing ratio of ethylenediamine to 1-adamantanamine within 5 to 32, and the mixing ratio of water to silica within 20 to 500 (Examples 38 to 48).

It was confirmed, as is clear from the results shown 25 in Table 10, that a DDR type zeolite membrane composite having the DDR type zeolite layer deposited within pores of substrate of $3\text{ }\mu\text{m}$ thickness or more, and the CO_2/CH_4 separation factor

separation factor of 2 or more at 100°C, especially, a DDR type zeolite membrane composite having the DDR type zeolite layer deposited within pores of substrate of 5 μm thickness or more, and a CO_2/CH_4 separation factor of 50 or more at 100°C, can be satisfactorily used as a gas separation membrane (Examples 38, 39, 43 to 46). A permeation speed of molecules becomes lower as the DDR type zeolite layer deposited within pores of substrate becomes thicker, thus the thickness of the DDR type zeolite layer deposited within pores of substrate is preferably within 3 to 6 μm when the porous substrate having the mean pore diameter of 0.6 μm is used.

DDR type zeolite membrane composites according to Examples 38 to 48 having the DDR type zeolite layer deposited within pores of substrate of 3 μm thickness or more has a high CO_2/CH_4 separation factor at 100°C, thus it can be assumed that occurrence of defects such as cracks are restrained even after heat treatment (calcination) for removing the structure-directing agent. Figure 12 is a graph of thermal expansion behaviors of a DDR type zeolite and alumina. As shown in Figure 12, the thermal expansion behaviors significantly differ between a DDR type zeolite and alumina. Thus, it can be assumed that when the thickness of a DDR type zeolite layer deposited within pores of substrate is below 5 times of the mean pore diameter, that is, when a DDR type zeolite layer is less than 3 μm , there is the large difference in the thermal expansion behaviors between a DDR type zeolite and an alumina substrate, thus the heat treatment causes the

formation of defects, and reduces molecule separation capability as in Comparative Examples 5 to 9. On the other hand, it can be assumed that when the thickness of a DDR type zeolite layer deposited within pores of substrate is 3 μm or more, preferably 5 μm or more, a DDR type zeolite layer deposited within pores of substrate reduces the difference in the thermal expansion behaviors between a DDR type zeolite membrane and the alumina substrate (porous substrate), thus restraining occurrence of defects after heat treatment.

10

Industrial Applicability

A DDR type zeolite membrane according to the present invention makes one or more kind of particular gases permeate selectively from a mixed gas containing particular gas components by a molecular sieving effect, thus can be satisfactorily used as a gas separation membrane. For example, a DDR type zeolite membrane is suitable for selectively separating carbon dioxide (CO_2) from a mixed gas of carbon dioxide and methane (CH_4) such as a natural gas.

20 A DDR type zeolite membrane may be used as a membrane reactor in combination with a catalyst.